Electronic Acknowledgement Receipt					
EFS ID:	1157571				
Application Number:	10826354				
Confirmation Number:	1037				
Title of Invention:	Surface emitting semiconductor laser and communication system using the same				
First Named Inventor:	Hiromi Otoma				
Customer Number:	25944				
Filer:	James Albert Oliff/Elizabeth Stenson				
Filer Authorized By:	James Albert Oliff				
Attorney Docket Number:	119498				
Receipt Date:	16-AUG-2006				
Filing Date:	19-APR-2004				
Time Stamp:	16:42:28				
Application Type:	Utility				
International Application Number:					
Dovment information:					

Payment information:

Submitted with Payment	no
------------------------	----

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		119498AAFR81606.pdf	446071	yes	14

Multipart Description				
Doc Desc	Start	End		
Amendment After Final	1	1		
Specification	2	7		
Applicant Arguments/Remarks Made in an Amendment	8	10		
Drawings	11	14		

Warnings:

Information:

Total Files Size (in bytes): 446071

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.